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SALIWANCHIK, LLOYD & SALIWANCHIK

A Professional Association

P.O. Box 142950

Gainesville, FL 32614-2950

Telephone (352) 375-8100

Facsimile (352) 372-5800

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TO: Examiner Steven J. Fulk ART UNIT 2891

FAX NO.: (571)-273-8300

FROM: Sarah J. knight

DATE: July 5, 2006

NO. OF PAGES (INCLUDING COVER SHEET): 5

SUBJECT/MESSAGE:

Re: U.S. Patent Application Serial No. 10/743,608; filed December 22, 2003
Methods for Forming Capacitors and Contact Holes of Semiconductor Devices
Simultaneously
(Nan)
Attorney Docket No. SUN-DA-116T

Attachment: Amendment Under 37 CFR §1.111 (4 page)

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July 5, 2006

Sarah J. Knight

Sarah J. Knight, Patent Agent

AMENDMENT UNDER 37 C.F.R. §1.111

Examining Group 2891

Patent Application

Docket No. SUN-DA-116T

Serial No. 10/743,608

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner : Steven J. Fulk
Art Unit : 2891
Applicant : Sang Woo Nam
Serial No. : 10/743,608
Filed : December 22, 2003
Confirm. No. : 7552
For : Methods for Forming Capacitors and Contact Holes of
Semiconductor Devices Simultaneously

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. §1.111

Sir:

In response to the Office Action dated April 5, 2006, please amend the above-identified
application as follows: